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**PATENT**  
Atty. Dkt. No. AMAT/6089.P1/CMP/ECP/RKK

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

re Application of:  
Kholodenko

Serial No.: 10/061,126

Confirmation No.: 2260

Filed: January 30, 2002

# For: Method And Apparatus For Encapsulation Of An Edge Of A Substrate During An Electrochemical Deposition Process

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

[illegible]

Group Art Unit: 1742

Examiner: Wesley A. Nicolas

# CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on 5/12, 2004, with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

5/12/04  
Date

Signature

**RESPONSE TO FINAL OFFICE ACTION DATED MARCH 12, 2004**

In response to the Final Office Action dated March 12, 2004, having a shortened statutory period for response set to expire on June 12, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/6089.P1, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.